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TRANSMITTAL FORM (to be used for all correspondence after initial filing)	Application Number	10/669,667
	Filing Date	9/23/2003
	First Named Inventor	Li et al.
	Art Unit	1765
	Examiner Name	Unassigned
Total Number of Pages in This Submission	Attorney Docket Number	MI22-2144

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EV550714913

SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT	
Firm or Individual	Mark S. Matkin, Reg. No. 32,268 Wells St. John, P.S.
Signature	
Date	5/20/05

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application Serial No.10/669,667
Filing Date September 23, 2003
Inventorship Li Li et al.
Assignee Micron Technology, Inc.
Group Art Unit 1765
Examiner Unassigned
Attorney's Docket No. MI22-2144
Title: Atomic Layer Deposition Methods of Forming Silicon Dioxide Comprising
Layers

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References - See Attached Form PTO-1449


The attached Form PTO-1449 is submitted in compliance with 37 CFR §1.56. Pursuant to FEDERAL REGISTER, Vol. 69, No. 182, pg. 56542 (September 21, 2004), no copies of any cited U.S. patents or U.S. published applications are included herewith. No admission is made regarding whether the listed references are prior art.


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This Supplemental Information Disclosure Statement is being filed within three months of the filing date of the application or before the mailing date of a first Office Action, whichever occurs last. Therefore, no fee is believed to be required. However, in the event that a fee is required for filing this Supplemental Information Disclosure Statement, please charge the fee specified under 37 C.F.R. § 1.17(p) to Deposit Account No. 23-0925.

Respectfully submitted,

Dated: 5-20-05

By: 
Mark S. Matkin
Reg. No. 32,268

Form PTO-1449	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	ATTY. DOCKET NO. MI22-2144	SERIAL NO. 10/669,667
 <p>LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)</p>		APPLICANT: Li Li et al.	
		FILING DATE September 23, 2003	GROUP 1765

U.S. PATENT DOCUMENTS							
*Examiner's Initials		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	2003/0064607 A1	4/3/2003	Leu et al.			
	AB	2003/0205823 A1	11/6/2003	Leu et al.			
	AC	2003/0032281 A1	2/13/2003	Werkhoven et al.			
	AD	2003/0129826 A1	7/10/2003	Werkhoven et al.			
	AE	2001/0041250 A1	11/15/2001	Werkhoven et al.			
	AF	2002/0081759 A1	6/27/2002	Huang et al.			
	AG						
	AH						
	AI						

FOREIGN PATENT DOCUMENTS								
		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
	AJ	WO 0166832	9/13/2001	PCT/ Werkhoven et al.				
	AK	EP 1107302	6/13/2001	EPO/Huang et al.				
	AL							

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)			
	AM		"Digital Chemical Vapor Deposition of SiO ₂ using a Repetitive Reaction of Triethylsilane/Hydrogen and Oxidation"; Sakaue et al.; Japanese Journal of Applied Physics, Vol. 30, No. 1B; January 1990; pp. L124-L127.
	AN		PCT/US2004/029478; Filed September 9, 2004; Search Report.
EXAMINER		DATE CONSIDERED	
<p>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</p>			